Information Disclosure Statement USSN 10/772,112 August 16, 2004 Page 3

Form PTO-1449 (Modified)	<b>ATTY DOCKET NO.</b> B-4246DIV 621598-8	U.S. SERIAL NO. 10/772,112	
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANT(S) Daniel YAP		
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	Document Number	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE or 102(e) DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Chan, W.K., et al., "Grafted Semiconductor Optoelectronics," IEEE Journal Of Quantum Electronics," Vol. 27, No. 3, pp. 717-725 (March 1991). Yi-Yan, A., et al., "Semiconductor-Film Grafting: A New Approach to OEICs, " Circuits & Devices, pp. 26-30 (May 1992).

EXAMINES (	<u></u>	DATE CONSIDERED	<del></del>
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